UNITED STATES PATENT AND TRADEMARK OFFICE **CERTIFICATE OF CORRECTION**

PATENT NO.

: 6,899,817 B1

Page 1 of 2

APPLICATION NO.: 10/031842

DATED

: May 31, 2005

INVENTOR(S)

: Volker Becker et al.

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

On the Title Page, # (57) Abstract, line 1, change "A method and a suitable device for carrying out this method" to -- A method and a device is for--

On the Title Page, # (57) Abstract, line 2, delete "is proposed, for"

On the Title Page, # (57) Abstract, line 2, change "a substrate (18), especially a silicon" to --a substrate, e.g., a silicon--

On the Title Page, # (57) Abstract, line 3, change "plasma (14)." to --plasma.--

On the Title, # (57) Abstract, line 6, delete "(14)"

On the Title, # (57) Abstract, line 6, change "a reactor (15)." to --a reactor.--

On the Title, # (57) Abstract, line 10, change "in particular" to --such as--

On the Title, # (57) Abstract, line 10, delete "(21)"

On the Title, # (57) Abstract, line 12, delete "(10)"

On the Title, # (57) Abstract, line 12, change "ICP source (13). For this" to --ICP source.--

On the Title, # (57) Abstract, line 13, change "the magnetic field" to -- The magnetic field--

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It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

On the Title, # (57) Abstract, line 15, delete "(10)"

On the Title, # (57) Abstract, line 16, change "plasma (14)." to --plasma.--

Signed and Sealed this

Page 2 of 2

Twenty-sixth Day of September, 2006

JON W. DUDAS
Director of the United States Patent and Trademark Office